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CONFIRMATION NO. 4772

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| SERIAL NUMBER 10/691,108 | FILING OR 371(c) DATE 10/22/2003 RULE | CLASS 216 | GROUP ART UNIT 1765 | ATTORNEY DOCKET NO. 10191/3399 |
| APPLICANTS Klaus Breitschwerdt, Filderstadt, GERMANY; Bernd Kutsch, Konz, GERMANY; Franz Laermer, Weil Der Stadt, GERMANY; | | | | |
| ** CONTINUING DATA ***** | | | | |
| ** FOREIGN APPLICATIONS ***** GERMANY 102 49350.2 10/23/2002 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/22/2004 | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | STATE OR COUNTRY GERMANY | SHEETS DRAWING 9 | TOTAL CLAIMS 5 |
| Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u> | | | | INDEPENDENT CLAIMS 4 |
| ADDRESS 26646 | | | | |
| TITLE Device and method for anisotropic plasma etching of a substrate, particularly a silicon element | | | | |
| FILING FEE RECEIVED 986 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |